


**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT PTO-1449**

Docket No. <b>52433/797</b>	Application No. <b>10/535,346</b>	
Applicant(s) <b>Tadashi ISHIKAWA et al.</b>	Examiner <b>SHEVIN, MARK L</b>	
Filing Date <b>October 3, 2005</b>	Confirmation No. <b>7148</b>	Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*
	6,171,415	January 9, 2001	Statnikov			

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	1-110707	04/27/1989	JP			Abstract corresponding to JP 1944370	
	1944370	06/23/1995	JP			Abstract corresponding to JP 1-110707	
	2002-220647	08/09/2002	JP			Abstract	
	2003-201549	07/18/2003	JP			Abstract	
	58-116954	07/12/1983	JP			Abstract	
	09-234585	09/09/1997	JP			Abstract	
	64-79320	03/24/1989	JP			Abstract	
	8-1514	01/09/1996	JP			Abstract	
	2003-113418	04/18/2003	JP			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	International Search Report dated 24 February 2004 issued in corresponding PCT Application No. PCT/JP03/14595.
	Kazuya YAMADA et al. "Cho Onpa Shot Peening ni yoru Zairyo Hyomenso no Nano-Kesshoka" The Japan Institute of Metals Koen Gaiyo, 2 November 2002, Vol. 131, page 265 [with English Translation]

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	